

**LIST OF PRIOR ART CITED BY APPLICANT**  
(Filed on April 15, 2005)

10/531434  
10/440 Equivalent

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Applicant(s): Kazunari KURITA and Jun FURUKAWA

Application No. 10/531,434 (Int'l Appln No. PCT/JP2003/013320 17OCT03) Group: 3200

Filed: 08/14/2000

Examiner: H. Heshew

**U.S. PATENT DOCUMENTS**

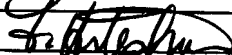
Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
F.H.	AA	6,045,610	04/04/2000	Park, et al.	—	—	✓
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	CLASS	Sub-Class	Translation YES	NO
F.H.	AL	2 324 652	10/28/1998	Great Britain	—	—	—	
F.H.	AM	11-1393	06/01/1999	Japan	—	—	US 6,045,610	
F.H.	AN	2002-47094	02/12/2002	Japan	—	—	Abstract only	
	AO							
	AP							
	AQ							
	AR							
	AS							
	AT							

**OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

F.H.	AX	Abstract only of Publication No. 2002-102385 published 13APR01, Mitsubishi Materials Silicon, "Silicon wafer without aggregate of dot-like defect"
	AY	
	AZ	

Examiner: 	Date: 3/2/07
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.